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PATENT APPLICATION
2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2823

Application No.: 09/857,803

Examiner: M. Estrada

Filed: June 11, 2001

Docket No.: 109725

For: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER

**NOTICE OF APPEAL TO THE BOARD OF
PATENT APPEALS AND INTERFERENCES**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the Decision of the Primary Examiner dated January 16, 2004.

The \$330.00 Appeal Fee (\$165.00 Small Entity) is:

 X Enclosed (our Check No. 153182)

 Not required (fee paid in prior appeal in this
application with no Board Decision on the merits).

The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 15-0461. Two duplicate copies of this document are enclosed.

Respectfully submitted,

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WPB:JMS/jms

Date: April 16, 2004

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

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